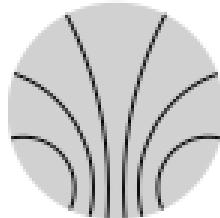


Measurement of the Photon Detection Efficiency of SiPMs and MPPCs

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Outline

- Overview of Characterisation Measurements
- Measurement of the Photon Detection Efficiency (PDE)
- Measurement of the device uniformity
- Summary and Outlook

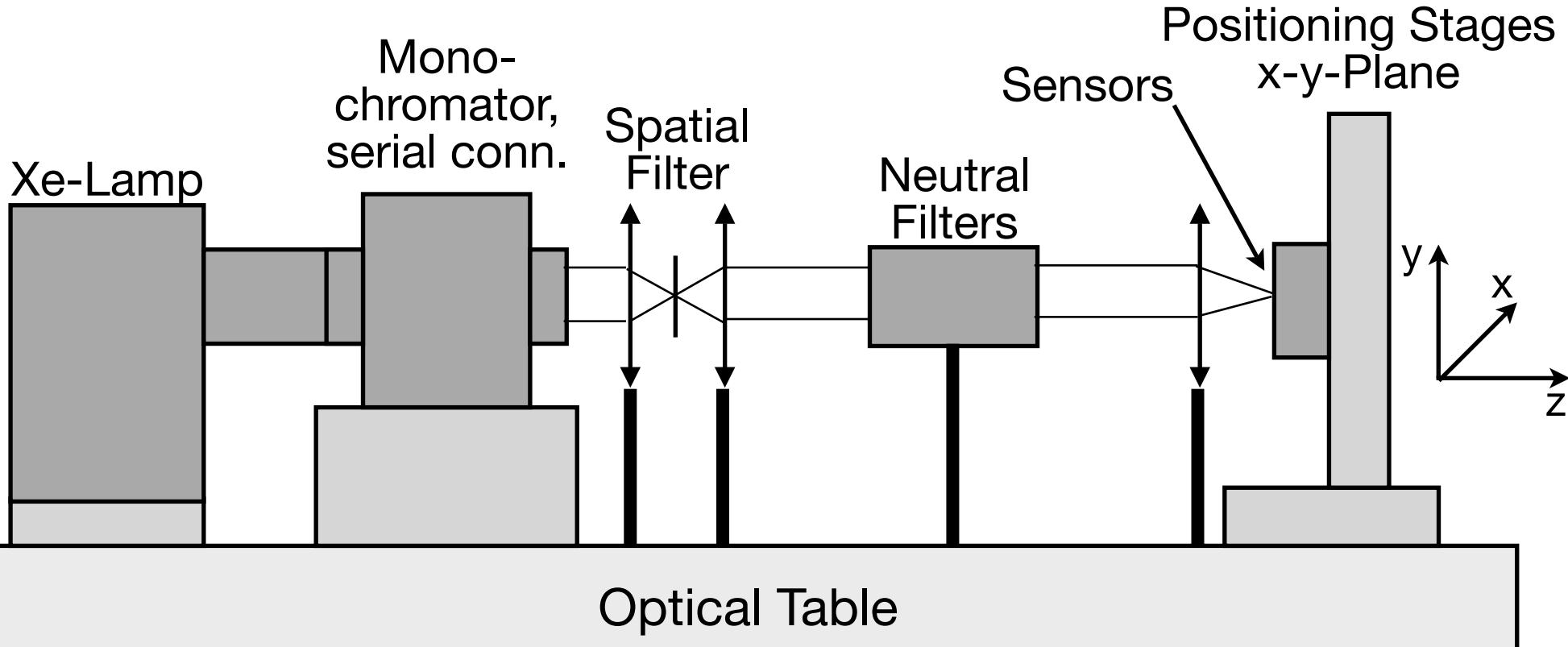
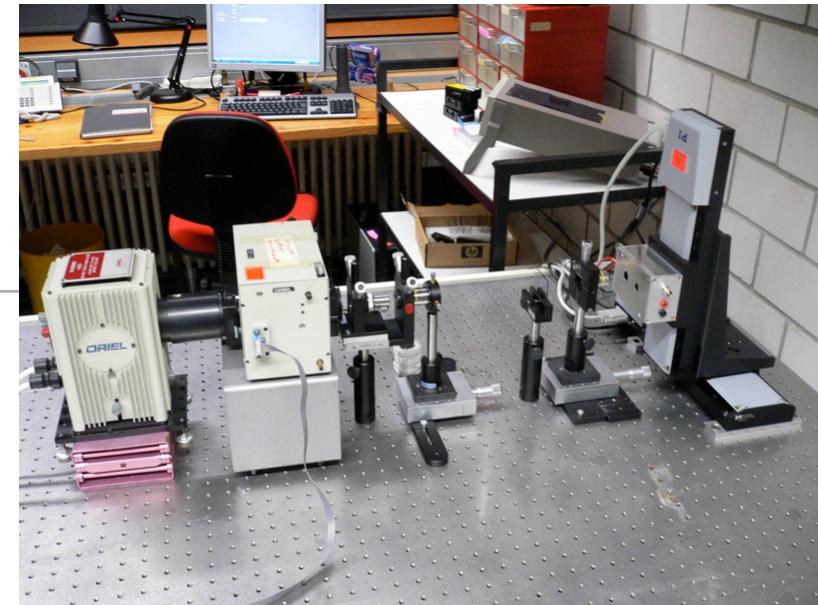
Measurement Summary

| Producer / SN | No. Pixels | I-V Char. | Dark-rate Char. | Gain Char. | PDE Char. | Surface/Uniformity tests |
|---|------------|-----------|-----------------|------------|-----------|--------------------------|
| Hamamatsu S10362-11-xxxC  | 100 | ✓ | ✓ | ✓ | | In Progress |
| | 400 | ✓ | ✓ | ✓ | ✓ | |
| | 1600 | ✓ | ✓ | ✓ | ✓ | |
| SensL SPMScint  | 1144 | ✓ | ✓ | ✓ | ✓ | |
| MEPHI-PULSAR (HCAL) | 1156 | | | | | |

This Talk

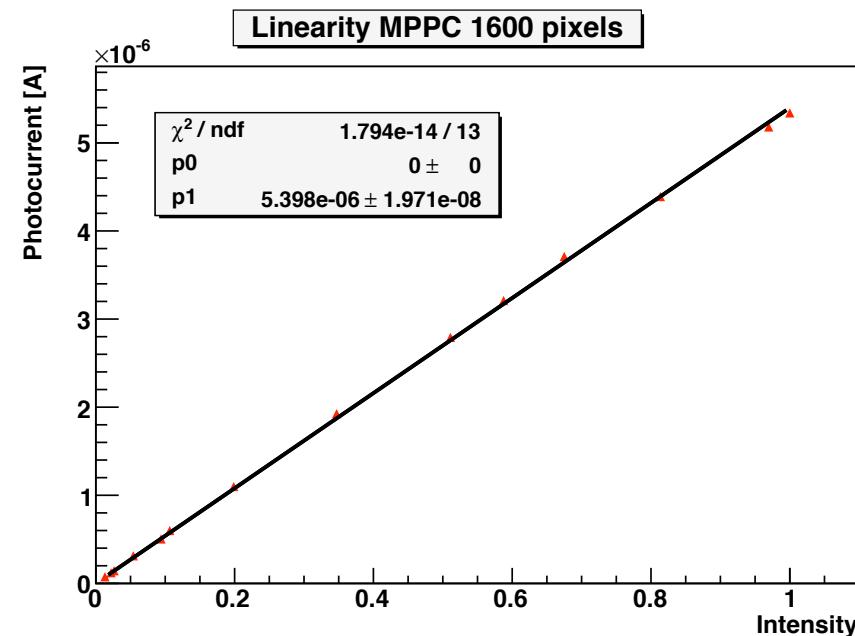
The Setup

- Automated wavelength scan
- Calibrated PIN diode used as reference (NIST traceable)
- Photocurrent measured with Pico-Amperemeter

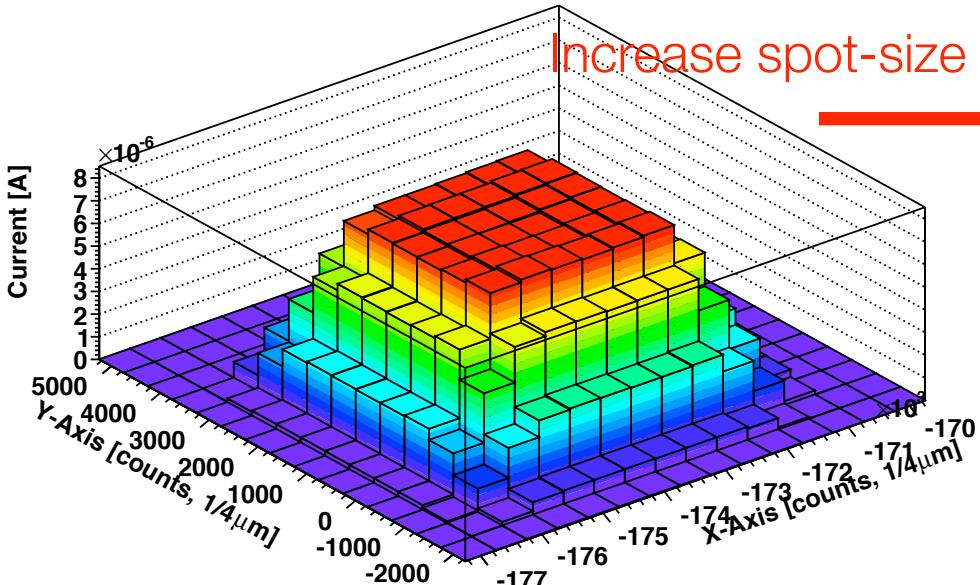


Optical Alignment

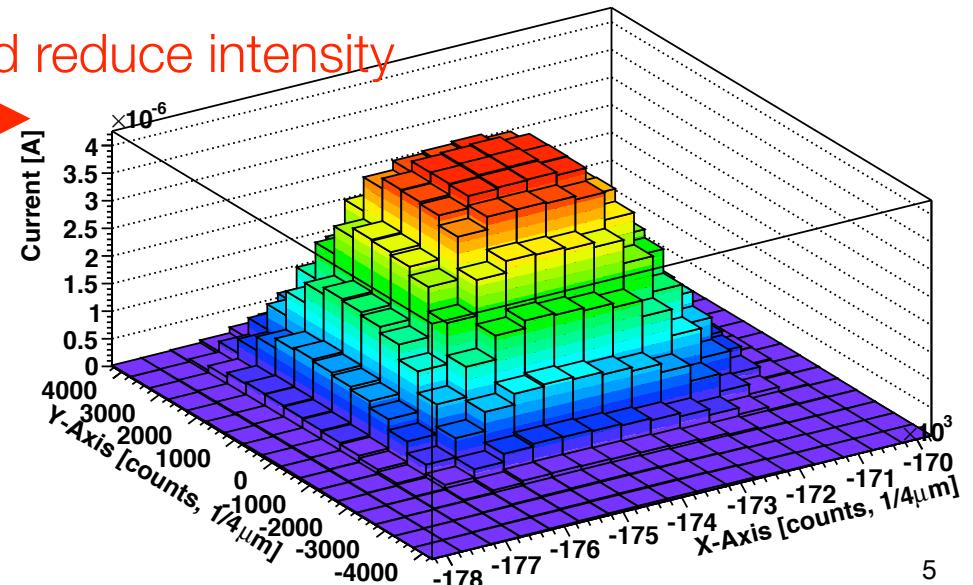
- We want to place a preferably large light spot at the centre of the MPPC/SiPM (linearity)
- Scan the sensor along x and y-axis
- Adjust spot size (focus)
- Take care that light spot isn't oversized (total width of scan < 2mm)
- Modify light Intensity to ensure linear response!



Area-Scan

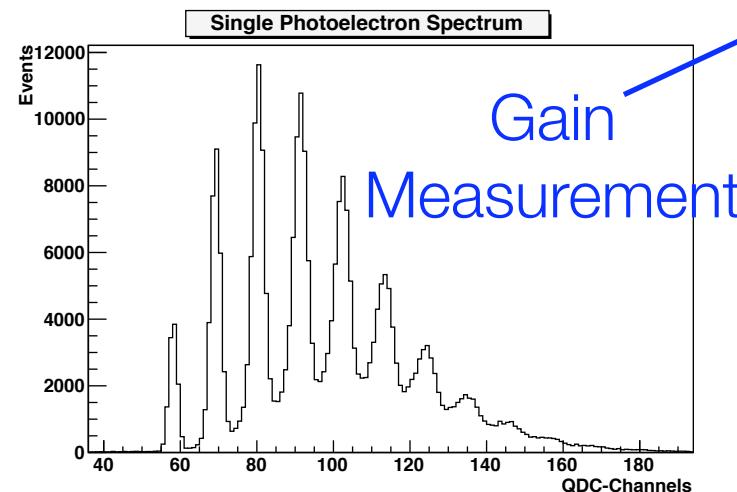


Area-Scan



PDE-calculation

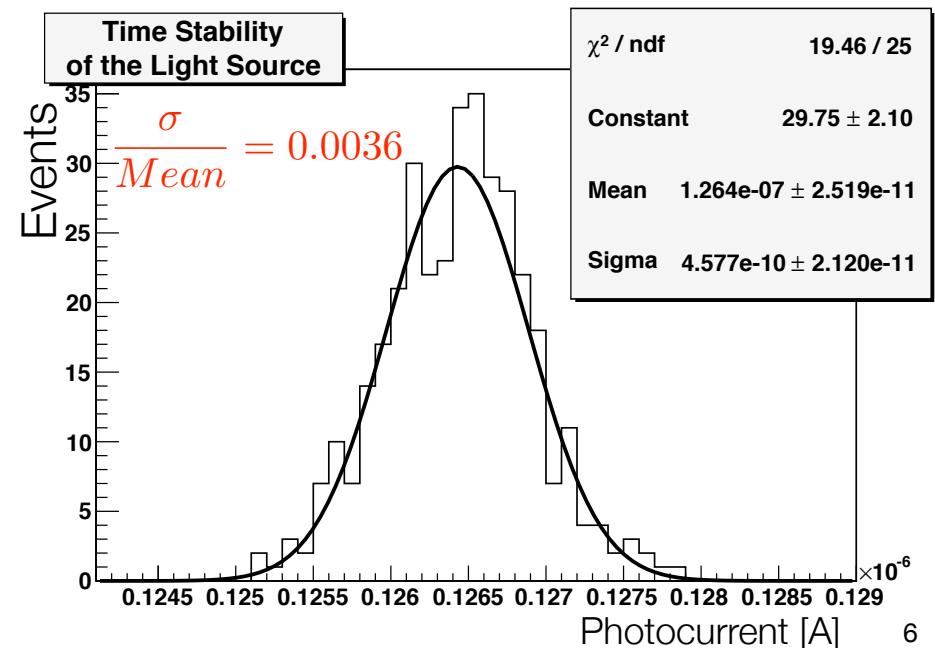
$$PDE = \frac{n_{pe}}{n_p} = \frac{I_{SiPM}}{M \cdot q_e \cdot n_p} = \frac{I_{SiPM} \cdot hc \cdot R}{M \cdot q_e \cdot I_{pin} \cdot \lambda}$$



PIN-diode Calibration Data-set

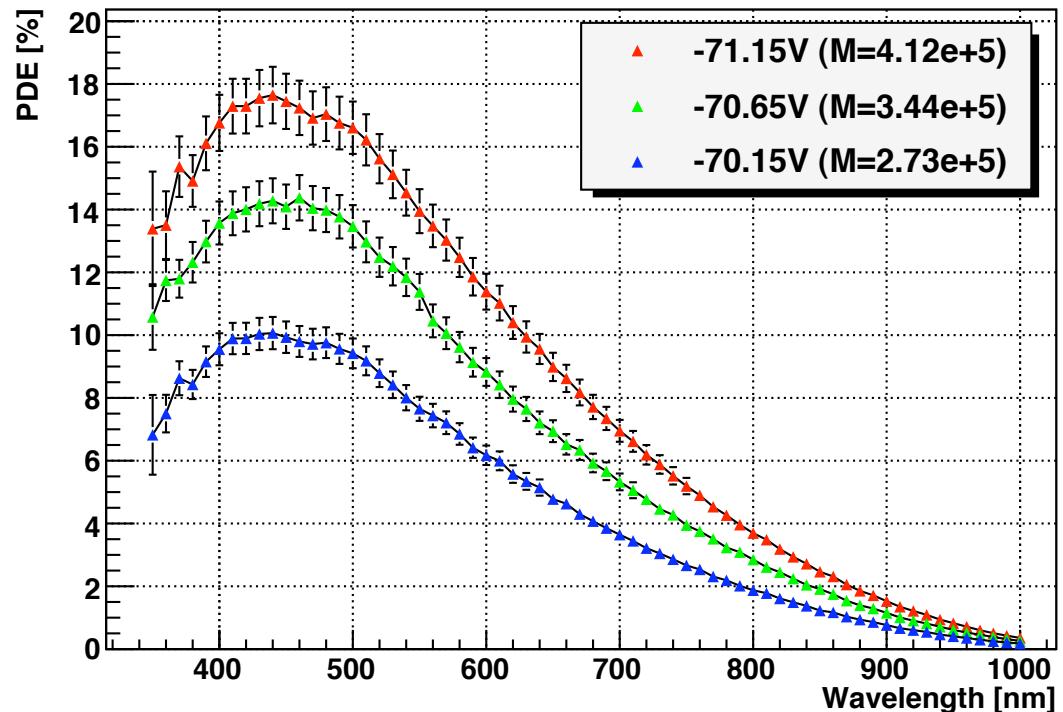
$$I_{SiPM} \cdot M \cdot q_e \cdot I_{pin} \cdot \lambda$$

Current
Measurement

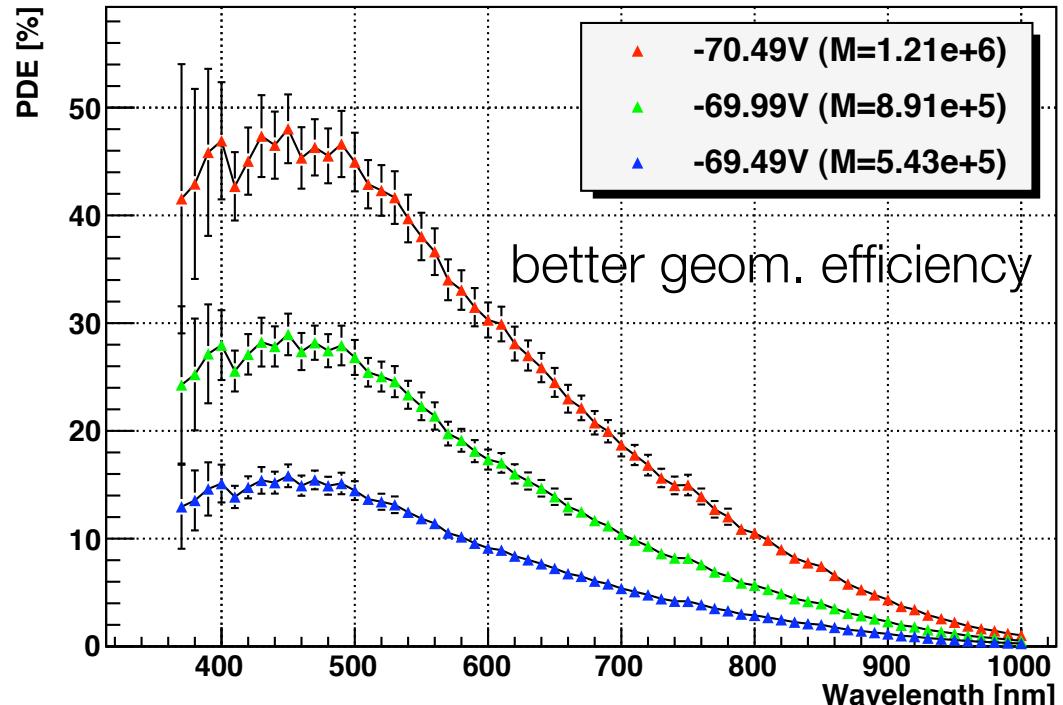


Measure I_{SiPM} and I_{pin} one after another, therefore the time stability of the light source is important.
DC-Current measurement cannot discriminate crosstalk and afterpulses -> Overestimation of the PDE-value

MPPC 1600 pixels @ room temperature



MPPC 400 pixels @ room temperature

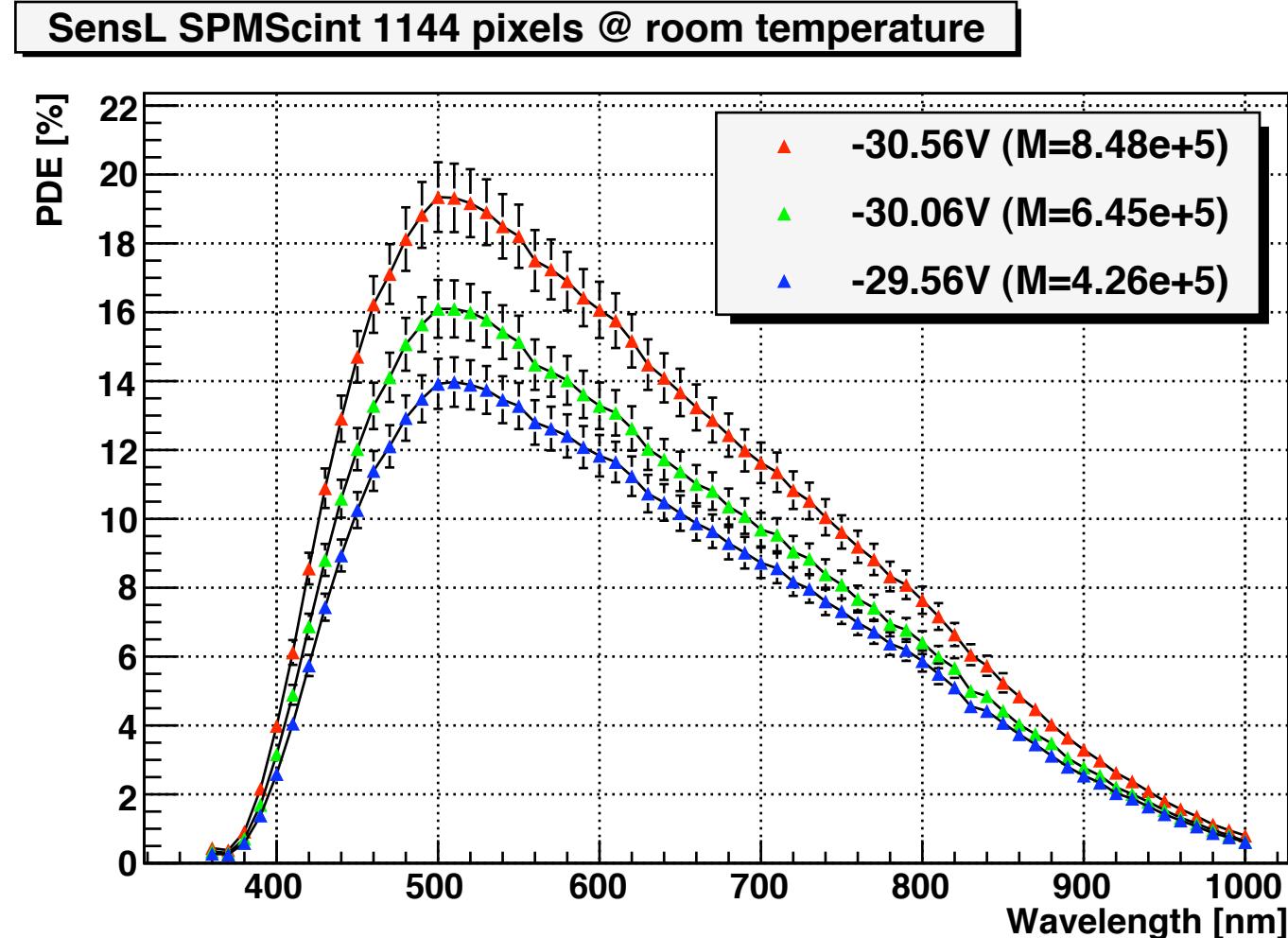


PDE Measurement Results MPPC

- High PDE value in the blue wavelength region
- Smaller dynamical range of the 400 pixel device makes the measurement difficult (low light intensity). S/N-ratio of the PIN-diode-signal limits the application below 400nm.
- We observe PDE values, smaller than the values quoted by HAMAMATSU ($\sim 10\%$ at nominal voltage)
- Precise gain measurement is crucial for the PDE evaluation. Measured gain values are consistent with the quoted values when taking into account temperature effects.

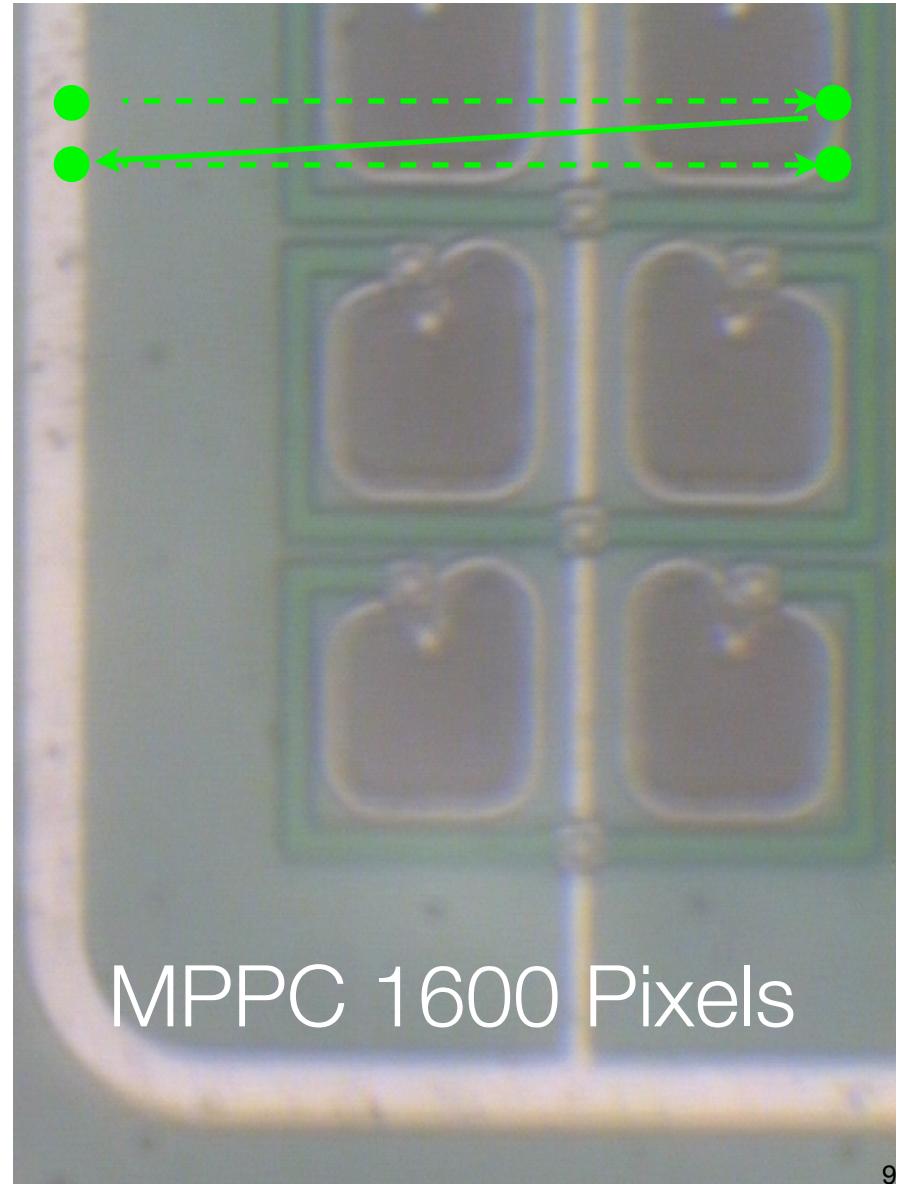
PDE Sensl SPM

- High PDE-value in the green wavelength region. (peaks at 520nm)
- Only small PDE-value for blue light
- Slightly higher PDE peak-value than the MPPC with 1600 pixels because higher geom. efficiency



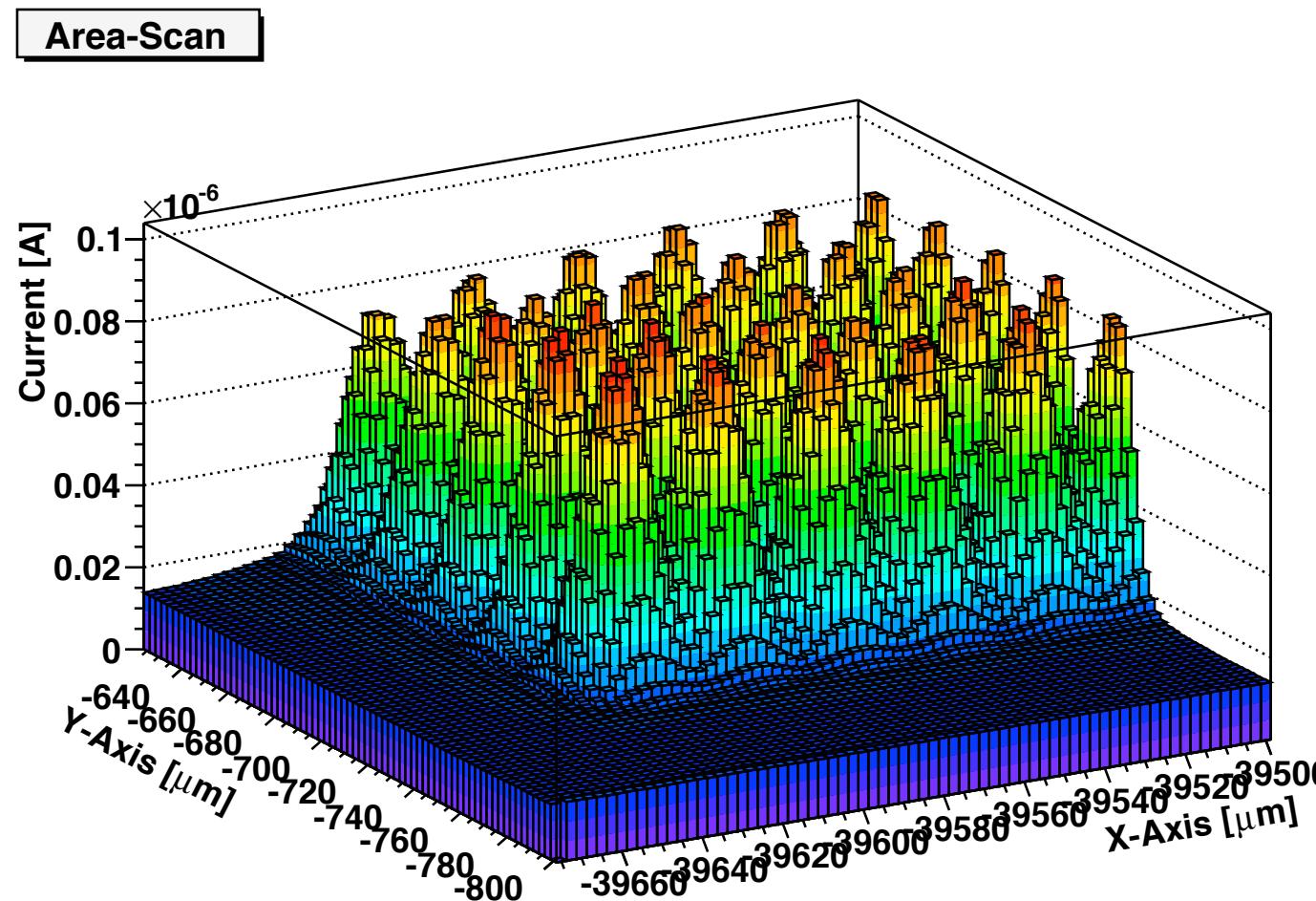
Uniformity Tests

- Scan the device along small light-spot
- If the bias is switched on, the device (gain)-uniformity can be tested.
- No Bias: Structure of the device (metal tracks, quenching resistors)
- Time for single point acquisition (moving & measuring) ~3s
 - time consuming
 - Scan only „interesting“ regions



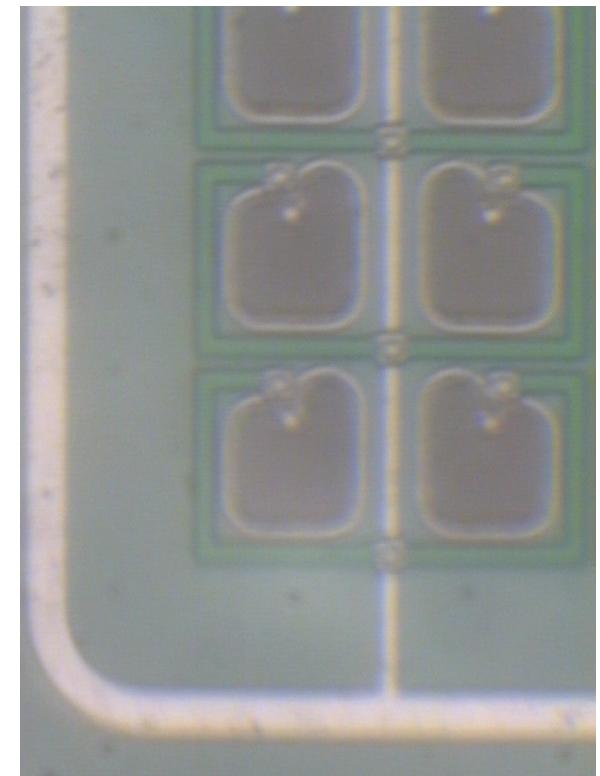
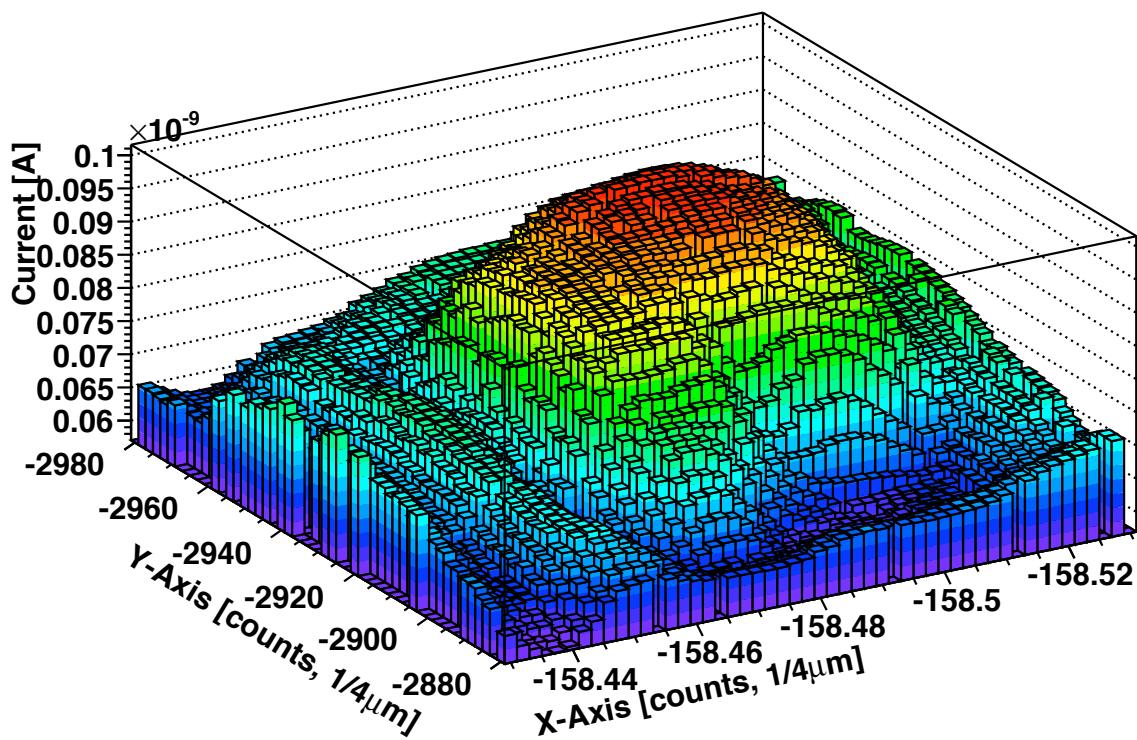
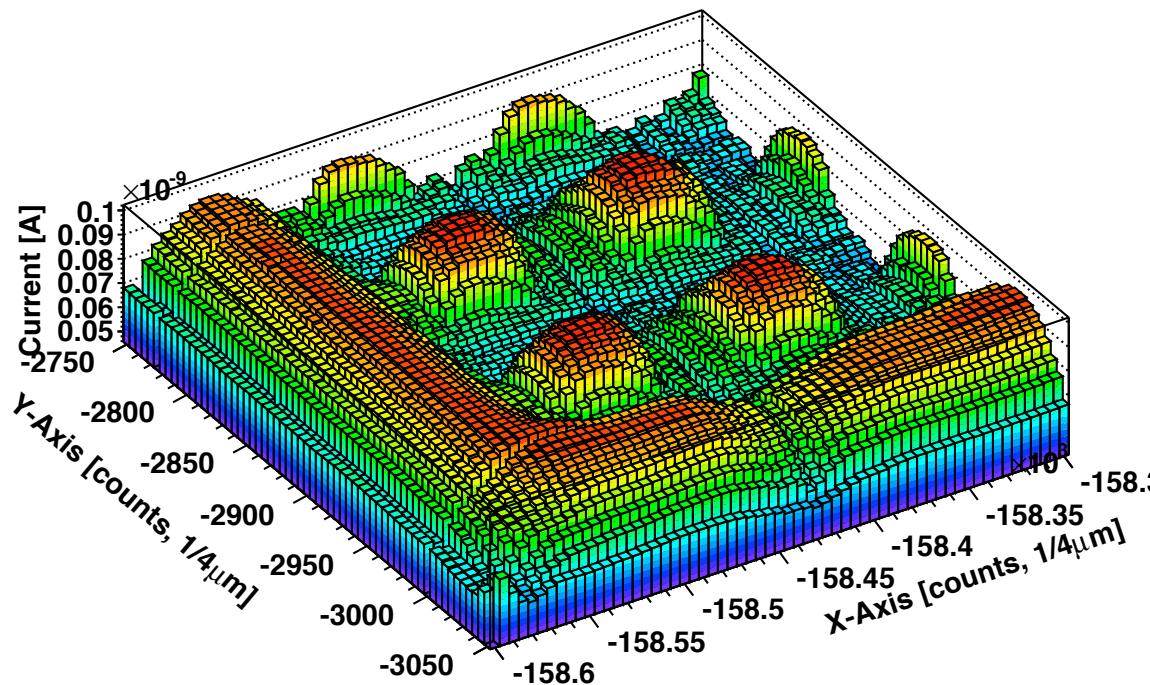
MPPC 1600 pixels (bias-voltage switched on)

- Step-size in x and y direction (bin-size): $2.5\mu\text{m}$
- Edge of the device
- Individual pixels are clearly visible
- No broken pixels



MPPC 1600 pixels (no bias-voltage)

- Device responses like a normal photodiode
- Detailed surface structure visible



Summary & Outlook

- PDE has been measured over wide spectral range (350 - 1000nm).
- Measured values for the PDE of the MPPCs are smaller than the the values quoted by HAMAMATSU.
- Device uniformity tests possible, but time consuming (3 seconds per point)
Detailed scan only for „interesting“ regions.
- Apply uniformity test to MEPHI-PULSAR SiPMs (long discharge)
- Accurate positioning and small spot size allows single pixel measurements (e.g. timing, PDE without geometrical effects)

Thank you for your attention!